

**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Oh et al.

Group Art Unit: 1795

**Serial No.: 10/615,842**

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

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**AMENDMENT C**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Official Action dated January 15, 2008, for which a shortened statutory period for reply has been extended up to and including June 15, 2008. Since June 15, 2008 falls on a Sunday, the response due date falls on June 16, 2008. A petition for a two-month Extension of Time is requested herewith. Favorable consideration is respectfully requested in view of the following Amendments and Remarks.